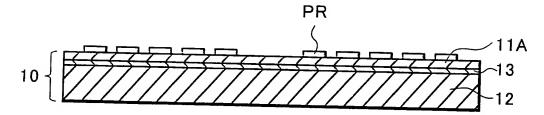
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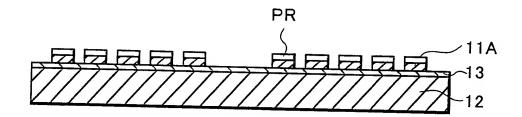
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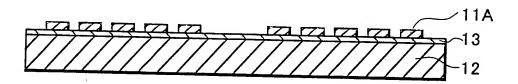
## FIG.1



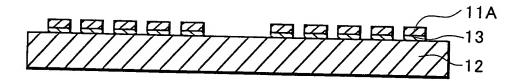
## FIG.2



## FIG.3



## FIG.4



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FIG.5

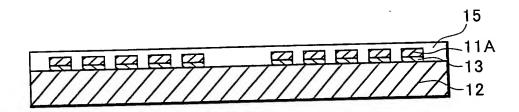


FIG.6

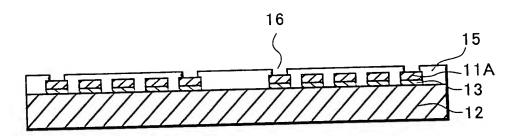


FIG.7

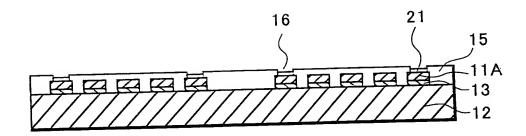
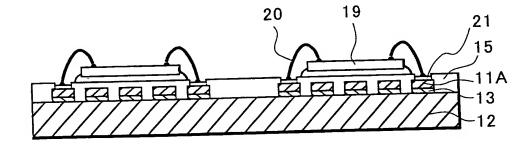


FIG.8



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FIG.9

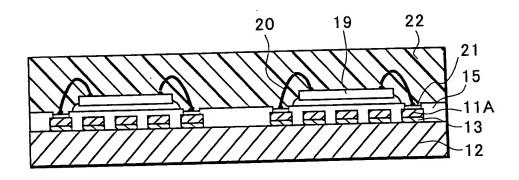


FIG.10

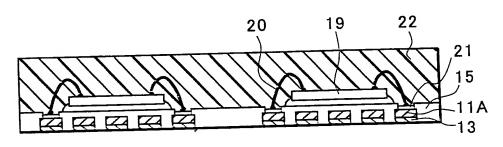
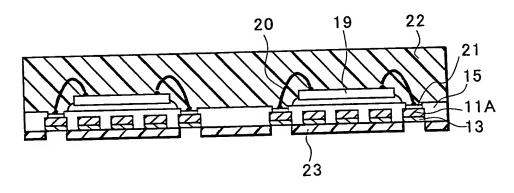


FIG.11



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FIG.12

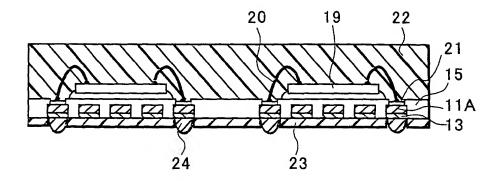
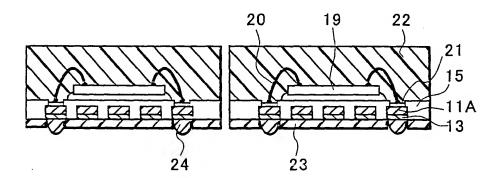
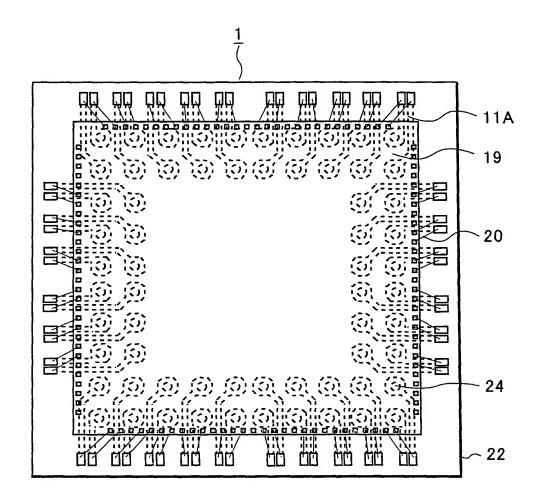


FIG.13



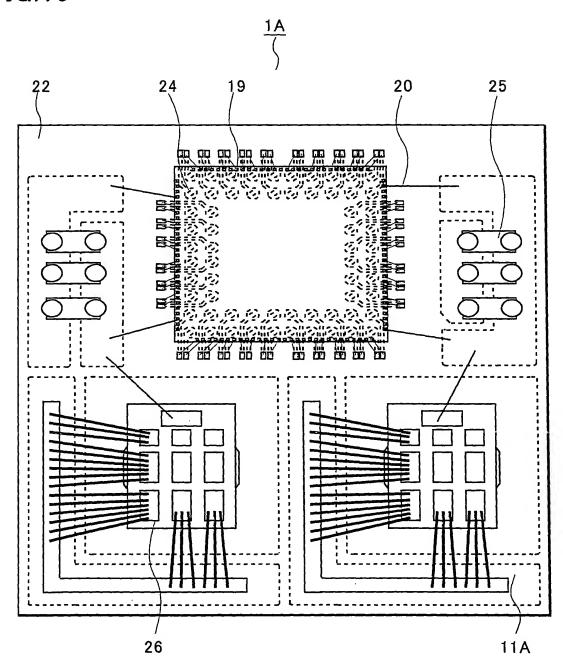
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FIG.14



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FIG.15

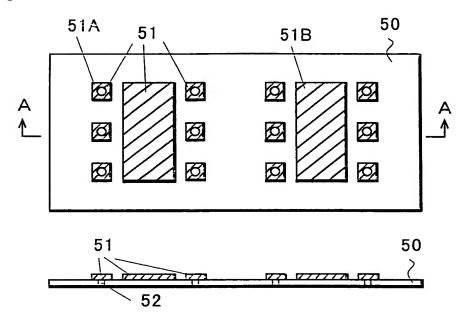


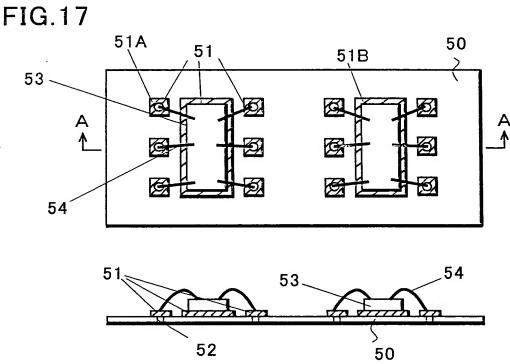
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FIG.16





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FIG.18A

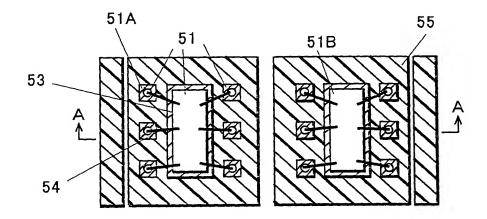


FIG.18B

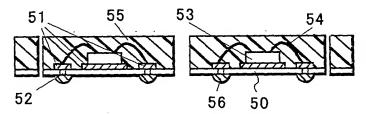
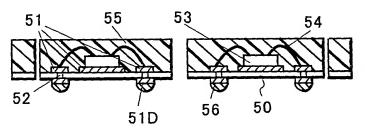


FIG.18C



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FIG.19

